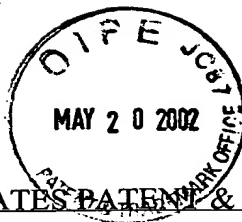


DOCKET NO. 198786US-2 RE



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

#8/10  
to  
Draftman  
5/23/02  
18

IN RE APPLICATION OF: : EXAMINER: CRANE, S

MITSUHIRO YANO ET AL :

GROUP ART UNIT: 2811

SERIAL NO. 09/891,925 :

FILED: JUNE 27, 2001 :

FOR: SEMICONDUCTOR DEVICE AND  
METHOD OF FABRICATING SAME

RECEIVED  
MAY 21 2002  
TECHNOLOGY CENTER 2800

LETTER REQUESTING APPROVAL OF DRAWING CHANGES

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

Please review for approval the proposed changes to the Formal Drawings shown in  
**RED** on the attached photocopies of the drawings.

Once these changes have been reviewed and approved by the Examiner in charge of  
this case, instructions for their implementation will be forwarded to an approved bonded  
draftsman.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

Gregory J. Maier  
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